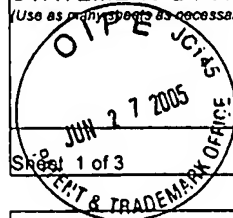


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Complete if Known	
Application Number	10/677,908
Filing Date	October 1, 2003
First Named Inventor	Fruhberger, Bernd
Group Art Unit	1244 2856
Examiner Name	Unknown D. Larkin
Attorney Docket No: SCS-1001-UT	

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Examiner Initials *	Cite No. 1	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ²

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS					T ²
Examiner Initials *	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
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Complete if Known

Application Number	10/677,908
Filing Date	October 1, 2003
First Named Inventor	Fruhberger, Bernd
Group Art Unit	1744 2856
Examiner Name	Unknown <i>D. Larkin</i>

Attorney Docket No: SCS-1001-UT

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DATE CONSIDERED *28 September 2007*

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